

Notice of References Cited	Application/Control No. 10/568,746	Applicant(s)/Patent Under Reexamination TAKI ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,527,594	06-1996	Kinoshita et al.	428/212
*	B	US-5,662,988	09-1997	Nakayama et al.	428/212
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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